



1722/1722

PATENT
03345-P0017A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Michael Heuken, <i>et al.</i>
Application No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1722
Examiner	Matthew J. Song

Mail Stop Issue Fee
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

***Transmittal of New Drawings to
Correct Informalities Within Three-Month Period
Of Response Set In Notice of Allowability (PTOL37)***

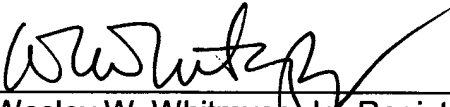
Dear Sir or Madam:

To correct the informalities in the drawings, Applicants submit herewith eleven sheets of formal drawings.

The three-month period of response set in the Notice of Allowability (PTOL 37) expires on September 28, 2006, and this submission is on or before the expiry date.

Respectfully submitted,

September 20, 2006


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Certificate of Mailing: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents; Post Office Box 1450; Alexandria, VA 22313-1450.

September 20, 2006


Daniella Crimi